

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	) Confirmation No.: 3788
Shinji MAEKAWA et al.	) Examiner: Stanetta D. Isaac
Application No.: 10/575,492	) Group Art Unit: 2812
Filed: April 12, 2006	)
For: METHOD FOR FORMING WIRING, METHOD	)
FOR MANUFACTURING THIN FILM	) Date: <u>January 4, 2010</u>
TRANSISTOR AND DROPLET DISCHARGING	)
METHOD	)

**INFORMATION DISCLOSURE STATEMENT**

**Mail Stop: RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that the Examiner initial a copy of this form and return it to the undersigned.

Since a request for continued examination is being filed concurrently herewith, no fees are believed to be due in connection with this filing. However, the Commissioner is hereby authorized to charge any fees in which may be required now, or credit any overpayment to Deposit Account No. 19-2380 (740756-2947).

Respectfully submitted,

**NIXON PEABODY, LLP**

Date: January 4, 2010

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